THEW

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Koji NOZAKI, et al

Group Art Unit: 1752

Serial No.: 10/623,679

Examiner: WALKE, AMANDA C

Filed: July 22, 2003

P.T.O. Confirmation No.: 5083

For:

RESIST PATTERN THICKENING MATERIAL, RESIST PATTERN AND

RPOCESS FOR FORMIMG THE SAME, AND SEMICONDUCTOR DEVICE

AND PROCESS FOR MANUFACTURING THE SAME

Attorney Docket No.: 030891 Customer Number: 38834

## AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

November 3, 2004

Sir:

In response to the Office Action dated August 3, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.